

## On-going R&D programs at CNES for Pollux

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2<sup>nd</sup> European Workshop on Pollux instrument





### • UV polarimeters for POLLUX

• UV coatings for POLLUX

## UV polarimeters for POLLUX (1/3)

- 3 potential concepts for POLLUX
  - Rotating plates (temporal modulation)
  - Static wedges (spatial modulation)
  - 3-mirrors configuration (temporal modulation)





Previous R&D program at CNES (2012-2016)

- Test of the two first concepts in the VIS domain at LESIA
- Good results (see M. Pertenaïs PhD thesis) for both rotating plates and static wedges (MgF<sub>2</sub> prototypes)

Static analyzer

Static analyzer

## UV polarimeters for POLLUX (2/3)

	Rotating plates (temporal modulation)	Static wedges (spatial modulation)
Accuracy (VIS)	I 0 <sup>-4</sup>	I 0 <sup>-2</sup>
Sensitivity (VIS)	I 0 <sup>-3</sup>	I 0 <sup>-2</sup>
TRL	4	3
FUV transmission	10 %	10 %
Advantages	High performances	<ul><li>Static</li><li>Single shot</li></ul>
Drawbacks	<ul><li>Moving parts</li><li>Multiple shots</li><li>Polarized fringes</li></ul>	<ul> <li>Need for large detectors with high dynamics</li> <li>Low TRL</li> <li>Sensitivity to the environment</li> </ul>
Common key points	<ul> <li>UV transmission</li> <li>Assembling technologies (glue, optical contact,)</li> </ul>	
Rotating plates concept proposed for Arago mission (higher TRL)		

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# **CCCS** UV polarimeters for POLLUX (3/3)

- Next step : test these polarimeters in the UV !
- > 2017 R&D objectives :
  - Adapt the existing rotating plates and static wedges prototypes to vacuum environment
  - Test these two concepts within the UV spectrograph at Observatoire de Meudon
  - Optional part (depending on parallel studies at IRAP) :
    - Design a 3-mirrors prototype and test it, first in the VIS domain, then in the UV
  - Identify a solution compatible with POLLUX requirements
- R&D program starting right now at LESIA ...
- but looking for a partner to co-fund a new PhD student



### UV coatings for POLLUX (1/1)

### Technological studies of UV coatings for [80 nm; 300 nm]

- Dichroïcs
- Reflective coatings
- Anti-reflection coatings

#### • To be adressed :

- Choice of substrates and materials
- Impact on polarization state
- Sensitivity to contamination
- Manufacturers not yet identified (... but very few)
- Beginning of this program : september of 2017



### Thank you for your attention